



PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Substitute of form 1449-A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

1

T

<i>Complete If Known</i>	
Application Number	10/027,951
Filing Date	December 19, 2001
First Named Inventor	Donald L. Yates
Group Art Unit	1746
Examiner Name	Unknown
Attorney Docket Number	3375.6US (95-0999.5)

U.S. PATENT DOCUMENTS

RECEIVED
NOV 20 2002
TO: 1700 MAIL ROOM

FOREIGN PATENT DOCUMENTS

**Examiner
Signature**

Date
Considered

3/10/04

'EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		Docket Number (Optional) 3375.6US (95-0999.4)	Application Number Not yet assigned
		Applicant Donald L. Yat s	
		Filing Date December 19, 2001	Group Art Unit Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>DU</i>	4,132,567	01/1979	Blackwood			
	4,197,000	04/1980	Blackwood			
	4,286,541	09/1981	Blackwood			<i>PRO</i>
	4,635,666	01/1987	Daley et al.			<i>10/02/95</i>
	4,682,615	07/1987	Burkman et al.			<i>10/02/95</i>
	4,911,761	03/1990	McConnell et al.			<i>10/02/95</i>
	4,984,597	01/1991	McConnell et al.			<i>10/02/95</i>
	4,997,490	03/1991	Vetter et al.			<i>10/02/95</i>
	5,069,235	12/1991	Vetter et al.			
	5,095,927	03/1992	Thompson et al.			
<i>DU</i>	5,115,576	05/1992	Roberson, Jr. et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>DU</i>	0,385,536	05/1990	EP				
	61-154130	07/1986	Japan				
	4-99025	03/1992	Japan				
	4-152525	05/1992	Japan				
<i>DU</i>	4-253332	09/1992	Japan				

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

<i>DU</i>	<i>DU</i>	Handbook of Semiconductor Wafer Cleaning Technology, editor W. Kern, Noyes Publications, pp. 131-51 and 405-15.
<i>DU</i>	<i>DU</i>	Koppenbrink et al., Particle Reduction on Silicon Wafers as a Result of Isopropyl Alcohol Vapor Displacement Drying after Wet Processing, Particles on Surfaces 2, editor K. Mittal, Plenum Press, pp. 235-43.
<i>DU</i>	<i>DU</i>	Marra et al., Physical Principles of Marangoni Drying, Langmuir, Vol. 7, No. 11, pp. 2748-55.

EXAMINER	<i>R. MARCUCCI</i>	DATE CONSIDERED	<i>3/10/04</i>
----------	--------------------	-----------------	----------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>		Docket Number (Optional) 3375.6US (95-0999.4)	Application Number Not yet assigned
		Applicant Donald L. Yates	
		Filing Date December 19, 2001	Group Art Unit Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>ALY</i>	5,186,192	02/1993	Netsu et al.			
	5,328,867	07/1994	Chien et al.			
	5,520,744	05/1996	Fujikawa et al.			
	5,660,642	08/1997	Britten			
	5,681,397	10/1997	Li			
	5,752,532	05/1998	Schwenkler			
	5,934,299	08/1999	Akatsu et al.			
	5,951,779	09/1999	Koyanagi et al.			
	5,958,146	09/1999	Mohindra et al.			
	6,125,863	10/2000	Bexten			
<i>ALM</i>	6,138,690	10/2000	Nakatani			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>LY</i>	4-354128	12/1992	Japan	1	1		
<i>ALY</i>	5-47734	02/1993	Japan	1	1		

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

<i>ALY</i>	Leenaars et al., <i>Marangoni Drying: A New Extremely Clean Drying Process</i> , Langmuir, Vol. 6, No. 11, pp. 1701-03.

EXAMINER	<i>A. MARUO</i>	DATE CONSIDERED	<i>3/10/04</i>
----------	-----------------	-----------------	----------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.



(2-92)

Sheet 1 of 1

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.